



IFX/1762

Docket No. 8733.565.00  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Yun-Ho JUNG

Customer No. 30827

Application No. 10/025,907

Confirmation No. 7489

Filed: December 26, 2001

Art Unit: 1762

For: APPARATUS AND METHOD OF  
CRYSTALLIZING AMORPHOUS SILICON

Examiner: Marianne L. Padgett

**Mail Stop Amendment**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AND RESPONSE AFTER NON-FINAL OFFICE ACTION**

Sir:

In response to the Office Action dated May 18, 2007, please amend the patent application identified above as follows:

**INTRODUCTORY COMMENTS**

**Amendments to the Specification** are reflected in the listing of claims that begin on page 2 of this paper.

**Amendments to the Claims** are reflected in the listing of claims that begin on page 4 of this paper.

**Remarks** begin on page 8 of this paper.